

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application)	PATENT APPLICATION
)	
Inventor(s): S. Brad Herner <i>et al.</i>)	Art Unit: 1762
)	
Appl. No.: 10/769,047)	Examiner: Chen, Bret P.
)	
Filed: January 30, 2004)	Docket No. SAND-01138US0
)	(formerly MA-100-I)
Title: LOW TEMPERATURE,)	
LOW-RESISTIVITY HEAVILY DOPED)	<u>Customer No. 64948</u>
<u>P-TYPE POLYSILICON DEPOSITION</u>)	

Assistant Commissioner for Patents
PO Box 1450
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RESPONSE TO NON-FINAL OFFICE ACTION

This paper is filed in response to the non-final Office Action of December 28, 2006, concerning the above-referenced patent application.

A COMPLETE LISTING OF CLAIMS begins on page 2 of this paper.

A DISCUSSION OF CLAIM AMENDMENTS begins on page 5 of this paper.

REMARKS begin on page 6.

A petition for a one-month extension of time under 37 CFR 1.136, together with the appropriate fee, is also submitted herewith.